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PATENT

UNITED STATES PATENT AND TRADEMARK OFFICE

Inventor(s): James E. Moon et al.

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Examiner: Not Yet Assigned

Title: **METHOD FOR FABRICATING MEMS AND MICROFLUDIC DEVICES USING LATENT MASKING TECHNIQUE**

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Assistant Commissioner for Patents
Washington, DC 20231

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Cynthia L. Losurdo
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AMENDMENT

Sir:

On Page 1 of the specification, please amend the title of the patent application identified above to METHOD FOR FABRICATING MEMS AND MICROFLUDIC DEVICES USING

LATENT MASKING TECHNIQUE

This amendment is submitted to render the title of the invention consistent with the title submitted by Applicants on Applicants' transmittal papers accompanying the application as filed.

Respectfully submitted,

April 18, 2003

Date

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